



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Satoshi Murakami, et al.                      Art Unit : 2814  
Serial No. : 10/006,043                                      Examiner : Nathan W. Ha  
Filed : December 4, 2001  
Title : SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE  
SAME

**MAIL STOP AMENDMENTS**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicants submit the references listed on the attached form PTO-1449. In accordance with the PTO's waiver of 37 CFR 1.98 (a)(2)(iii), only copies of the foreign patent documents are enclosed.

Submitted herewith is an English translation of the following foreign language references, or portions thereof:

Desig. ID	Source
AM	Japan 2001-005426 – English Abstract: DIALOG(R) File 352: Derwent WPI (2002); Accession No. 013641375 and family to European Patent No. 1 063 630 (Desig. ID “AL”).
AN	Japan 2002-057162 – English Abstract: DIALOG(R) File 345: Inpadoc/Fam. & Legal Stat (2003); Accession No. 17577636 and family to U.S. Patent Publication No. 2001-0055841 (Desig. ID “AA”).
AO	Japan 3281848 – English Abstract: DIALOG(R) File 345: Inpadoc/Fam. & Legal Stat (2003); Accession No. 14614258 and family to U.S. Patent No. 6,084,579 (Desig. ID “AH”).

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Attorney's Docket No.: 07977-289001 / US5338

This statement is being filed before the receipt of a first Office Action on the merits after the filing of a RCE. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: January 7, 2005

  
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JFH/adt  
40261019.doc

Substitute Form PTO-1449  
(Modified)U.S. Department of Commerce  
Patent and Trademark OfficeAttorney's Docket No.  
07977-289001Application No.  
10/006,043**Information Disclosure Statement  
by Applicant**

(Use several sheets if necessary)

(37 CFR 1.98(b))

Applicant  
Satoshi Murakami, et al.Filing Date  
December 4, 2001Group Art Unit  
2814**U.S. Patent Documents**

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	2001-0055841	12/27/2001	YAMAZAKI et al.			04/12/2001
	AB	2002-0068388	06/06/2002	MURAKAMI et al.			12/04/2001
	AC	2002-0153844	10/24/2002	KOYAMA			03/11/2002
	AD	4,792,210	12/20/1988	MAURICE			01/27/1987
	AE	5,234,541	08/10/1993	SHANNON et al.			05/29/1991
	AF	5,824,235	10/20/1988	YAMAZAKI et al.			07/29/1996
	AG	5,938,942	08/17/1999	YAMAZAKI et al.			07/13/1998
	AH	6,084,579	07/04/2000	HIRANO			11/25/1997
	AI						
	AJ						
	AK						

**Foreign Patent Documents or Published Foreign Patent Applications**

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	AL	EP1 063 630	27 DEC 2000	EUROPE			In English	
	AM	JP2001-005426	12 JAN 2001	JAPAN			Abstract	
	AN	JP2002-057162	22 FEB 2002	JAPAN			Abstract	
	AO	JP-3281848	22 FEB 2002	JAPAN			Abstract	
	AP							

**Other Documents (include Author, Title, Date, and Place of Publication)**

Examiner Initial	Desig. ID	Document
	AQ	
	AR	
	AS	
	AT	

Examiner Signature

Date Considered

EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.